



ELECTRONIC COPY

LG760563990  
Report verification at igi.org



December 29, 2025  
IGI Report Number **LG760563990**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **MARQUISE BRILLIANT**  
Measurements **10.65 X 5.31 X 3.33 MM**  
**GRADING RESULTS**  
Carat Weight **1.09 CARAT**  
Color Grade **D**  
Clarity Grade **VVS 2**

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GRADING RESULTS

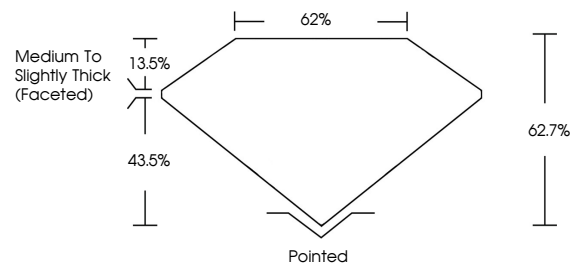
Carat Weight **1.09 CARAT**  
Color Grade **D**  
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG760563990**

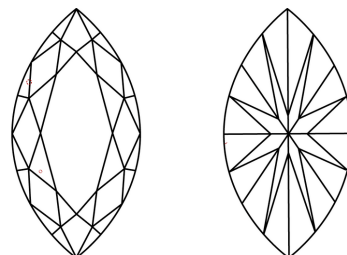
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

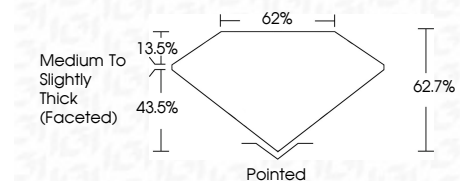
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS<sup>1-2</sup> VS<sup>1-2</sup> SI<sup>1-2</sup> I<sup>1-3</sup>  
Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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**MARQUISE BRILLIANT**  
**1.09 CARAT**  
**D**  
Carat Weight  
Color Grade  
Clarity Grade **VVS 2**  
Depth **62.7%**  
Table **62%**  
Girdle  
Medium to Slightly Thick (Faceted)  
Culet Pointed  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG760563990**  
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